REMARKS

Claims 22-32 were previously pending for examination in this application. Claims 1-21 and 33-41 were withdrawn. Claims 1-21 and 33-41 have now been canceled without prejudice or disclaimer. Claim 22-24, 27 and 29-32 have been amended. New method claims 42-60 have been added. As a result, claims 22-32 and 42-60 are pending for examination with claims 22 and 42 being independent claims. No new matter has been added.

Preliminary Matters

The Applicants note with appreciation that initialed copies of several Information Disclosure Statements (IDSs) submitted by the Applicants were attached to the Office Action mailed September 23, 2004. However, initialed copies of IDSs submitted on February 5, 2002 and July 26, 2002 were not provided to the Applicants. Copies of the IDSs submitted on February 5, 2002 and July 26, 2002 are provided herewith along with corresponding copies of postcards stamped by the USPTO. The Applicants respectfully request that initialed copies of the IDSs submitted on February 5, 2002 and July 26, 2002 be sent to the Applicants by the Examiner with the next correspondence.

Rejections Under 35 U.S.C. §102

Claims 22-32 were rejected under 35 U.S.C. §102(b) as allegedly being anticipated by U.S. Patent No. 5,867,302 to Fleming (hereinafter Fleming). The Applicants disagree with the Examiner's characterization of Fleming and respond as follows.

Claim 22 as amended recites "An electrostatically-actuated diffractive optical processor having ... an axis normal to at least a portion of a surface of [a] substrate ... comprising: a plurality of first mirror surfaces ...; [and] a plurality of second mirror surfaces, at least a portion of each of the plurality of second mirror surfaces ... optically adjacent to at least a corresponding one of the plurality of first mirror surfaces for light projected parallel to the axis." The term "optically adjacent surfaces" is defined on page 7, line 2 et. seq. as meaning surfaces that, for light of a specified angle of projection, are located such that when light is projected onto the surfaces at the specified angle, the light is projected onto one or the other surface, and substantially no light impinges on points between the surfaces.

An example of an optical processor having surfaces that are optically adjacent for light projected parallel to an axis is provided in FIG. 3 of the Applicants' specification, where surface 210b is optically adjacent to surface 215b for light 350 projected parallel to an axis Z which is normal to a surface of substrate 330.

By contrast, in FIG. 4b of Fleming (the figure to which the Office Action refers), Fleming discloses two mirror surfaces 38 and 38' that are not optically adjacent for light projected parallel to an axis perpendicular to a surface of a substrate. Rather, when light is projected parallel to an axis normal to a surface of substrate 12, the light is projected into a gap located between mirror surfaces 38 and 38'. In this regard, the device disclosed in Fleming is like the prior art optical processor discussed with reference to FIG. 1 of the Applicants' specification.

Accordingly, claim 22 is patentable over Fleming. Claims 23-32 depend from claim 22 and are patentable for at least the same reasons as claim 22. Withdrawal of these rejections is respectfully requested.

The Applicants note that other than the amendment to claim 22 regarding optical adjacency being specified for light projected parallel to the axis, as discussed above in the Remarks section, the remaining amendments to claim 22 and other claims are made to clarify the claimed subject matter and not for reasons of patentability.

New claims 42-51 depend from claim 22 and are patentable for at least the same reasons as claim 22.

New method claims 52-60 are patentable over Flemming at least because they recite a step of "providing ... an optical processor ... comprising ... second mirror surfaces optically adjacent to at least a corresponding one of [a] plurality of first mirror surfaces for light projected parallel to [an axis normal to at least a portion of a surface of a substrate of the optical processor]."

CONCLUSION

In view of the foregoing amendments and remarks, reconsideration is respectfully requested. This application should now be in condition for allowance; a notice to this effect is respectfully requested. If the Examiner believes, after this amendment, that the application is not

in condition for allowance, the Examiner is requested to call the Applicants' attorney at the telephone number listed below.

If this response is not considered timely filed and if a request for an extension of time is otherwise absent, the Applicants hereby request any necessary extension of time. If there is a fee occasioned by this response, including an extension fee, that is not covered by an enclosed check, please charge any deficiency to Deposit Account No. 50/2762.

Respectfully submitted, Erik R. Deutsch, et al., Applicants

By:

Geffrey B. Powers, Reg. No. 45,021 LOWRIE, LANDO & ANASTASI, LLP

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Cambridge, Massachusetts 02142

United States of America Telephone: 617-395-7000 Facsimile: 617-395-7070

Docket No.: P0743/7001 (SJH) Date: December 22, 2004



Serial No. 69/975, 169 File No. Po743 Title: Actuatable D. ffractive Optical Application of Erik R. Deutsch et al	
The U.S. PTO Mail Room acknowledges receipt of the following	on the date stamped hereon:
[] Mailing by Express Mail (37 CFR 1.10) Express Mail Label No. [] Patent Application [] Non-provisional [] Provisional Incl pages, (pgs) Specification, (pgs) Abstract, (pgs) Claims (# claims) [] Design Patent Application [] Declaration(s) Sheet(s) (FIGS) [] Formal [] Informal [] Utility Patent Application Transmittal [] Fee calculation sheet (x2) [] CPA Transmittal [] Verified Statement claiming smallentity status [] Assignment and Cover Sheet	Provisional Application Cover Sheet Multiple Dependent Claim Fee Sheet Inf. Discl. Statement, PTO Form 1449 Priority Document(s) #_ Copy of Notice to File Missing Parts Amendment/Response Petition for Ext. of Time (x2) Issue Fee Transmittal Letter to Official Draftsperson Notice of Appeal Brief (x3) Check for \$_ Check #_ Transmittal Letter (x2) Cert. of Mailing under 37 CFR 1.8(a)
DATE MAILED TO STATE	2



ATTORNEY'S DOCKET NO: P0743/7001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Erik R. Deutsch et al.

Serial No:

09/975,169

Filed:

October 11, 2001

For:

Actuatable Diffractive Optical Processor

Examiner:

Not Yet Assigned

Art Unit:

2872

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Commissioner for Patents, Washington, D.C. 20231, on the day of February, 2002.

Steven J. Henry Reg. No. 27,900

Commissioner For Patents Washington, D.C. 20231

Sir:

Transmitted herewith are the following documents:

[X] Information Disclosure Statement, PTO Form 1449 and references

[X] Return Receipt Postcard

If the enclosed papers are considered incomplete, the Mail Room and/or the Application Branch is respectfully requested to contact the undersigned at (617) 720-3500, Boston, Massachusetts.

No check is enclosed to cover the filing fee. If the fee is insufficient, the balance may be charged to the account of the undersigned, Deposit Account No. 23/2825. A duplicate of this sheet is enclosed.

Respectfully Submitted,

Steven J. Henry

Reg. No. 27,900

Wolf, Greenfield & Sacks, P.C.

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Boston, MA 02210-2211

(617) 720-3500

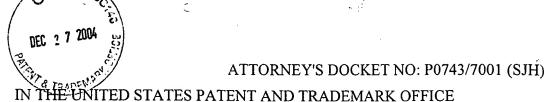
Docket No:

P0743/7001

Date:

February 5, 2002

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Applicant:

Erik Deutsch, et al.

Serial No:

09/975,169

Filed:

October 11, 2001

For:

ACTUATABLE DIFFRACTIVE OPTICAL PROCESSOR

Examiner:

Not Yet Assigned

Art Unit:

2872

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Commissioner for Patents, Washington, D.C. 20231, on the day of February, 2002.

Steven J. Henry, Reg. No. 27,900

Commissioner for Patents Washington, D.C. 20231

STATEMENT FILED PURSUANT TO THE DUTY OF DISCLOSURE UNDER 37 CFR §§1.56, 1.97 AND 1.98

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. §§1.56, 1.97 and 1.98, the Applicant requests consideration of this Information Disclosure Statement.

PART I: Compliance with 37 C.F.R. §1.97

This Information Disclosure Statement has been filed before the mailing date of a first Office Action on the merits in the above-identified case. No fee or certification is required.

PART II: Information Cited

The Applicant hereby makes of record in the above-identified application the information listed on the attached form PTO-1449 (modified). The order of presentation of the references should not be construed as an indication of the importance of the references.

Art Unit: 2872

<u>PART III: Explanation of Non-English Language References and Remarks Concerning Other Information Cited</u>

The following is a concise explanation of the relevance of each non-English language reference listed on the attached form PTO-1449 (modified):

The following are remarks concerning the other information cited:

PART IV: Remarks

Documents cited on the attached form PTO-1449 (modified) are enclosed unless otherwise indicated on the attached form PTO-1449 (modified). It is respectfully requested that:

- 1. The Examiner consider completely the cited information, along with any other information, in reaching a determination concerning the patentability of the present claims;
- 2. The enclosed form PTO-1449 be signed by the Examiner to evidence that the cited information has been fully considered by the Patent and Trademark Office during the examination of this application;
- 3. The citations for the information be printed on any patent which issues from this application.

By submitting this Information Disclosure Statement, the Applicant makes no representation that a search has been performed, of the extent of any search performed, or that more relevant information does not exist.

By submitting this Information Disclosure Statement, the Applicant makes no representation that the information cited in the Statement is, or is considered to be, material to patentability as defined in 37 C.F.R. §1.56(b).

By submitting this Information Disclosure Statement, the Applicant makes no representation that the information cited in the Statement is, or is considered to be, in fact, prior art as defined by 35 U.S.C. §102.

Notwithstanding any statements by the Applicant, the Examiner is urged to form his own conclusion regarding the relevance of the cited information.

Art Unit: 2872

An early and favorable action is hereby requested.

Respectfully submitted, Erik Deutsch et al., Applicant(s)

By

Steven J. Henry, Reg. No. 27,9000 Wolf, Greenfield & Sacks, P.C. 600 Atlantic Avenue Boston, MA 02210 Telephone (617) 720-3500

Docket No. P0743/7001
Dated: February , 2002
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FORM PTO-1449/A and B (Modified)

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

of

2

APPLICATION NO.:

09/975,169

ATTY. DOCKET NO.: P0743/7001

FILING DATE:

October 11, 2001

APPLICANT:

Erik Deutsch et al.

GROUP ART UNIT:

2872

EXAMINER: Not Yet Assigned

U.S. PATENT DOCUMENTS

Examiner's	Cite	U.S. Patent Document		Name of Patentee or Applicant of Cited	Date of Publication or of issue
Initials# No.		Number	Kind Code	Document	of Cited Document MM-DD-YYY
		4,731,670		Allen et al.	03-15-1988
		4,805,038		Seligson	02-14-1989
		5,115,344		Jaskie	05-19-1992
		5,212,582		Nelson	05-18-1993
		5,781,670		Deacon et al.	07-14-1998
		5,794,023		Hobbs et al.	08-11-1998
		5,836,203		Martin et al.	11-17-1998
	·	5,847,859		Murata	12-08-1998
		5,870,221		Goossen	02-09-1999
		5,905,589		Tanaka et al.	05-18-1999
		5,933,277		Troxell et al.	08-03-1999
		5,953,161		Troxell et al.	09-14-1999
· ·		6,014,257		Furlani et al.	01-11-2000
		6,031,652		Furlani et al.	02-29-2000
		6,038,057		Brazas, Jr. et al.	03-14-2000
		6,067,183		Furlani et al.	05-23-2000
		6,072,620		Shiono et al.	06-06-2000
		6,088,148		Furlani et al.	07-11-2000
		6,130,770		Bloom	10-10-2000
		6,144,481		Kowarz et al.	11-07-2000
		6,175,443	B1	Aksyuk et al.	01-16-2001
		6,181,458	B1	Brazas, Jr. et al.	01-30-2001
		6,233,087	Bl	Hawkins et al.	05-15-2001
		6,238,581	B1	Hawkins et al.	05-29-2001
		6,243,194	Bl	Brazas, Jr. et al.	06-05-2001
		6,282,012	B1	Kowarz et al.	08-28-2001
		6,282,213	B1	Gutin et al.	08-28-2001
· · ·		6,284,560	B1	Jech, Jr. et al.	09-04-2001
		6,288,824	B1	Kastalsky	09-11-2001

FOREIGN PATENT DOCUMENTS

Examiner's	Cite	For	Foreign Patent Document Name of Patentee or Applicant of Cited				Translation
Initials#	No.	Office/ Country	Number	Kind Code	Document (not necessary)	Publication of Cited Document MM-DD-YYYY	(Y/N)
		WO	91/02991	A·l		03-07-1991	
· ·		WO	98/41893	Al		09-24-1998	
		WO	01/11394	Al		02-15-2001	

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\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\	APPLICATION NO.:	09/975,169	ATTY. DOCKET NO.: P0743/7001	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT	FILING DATE:	October 11, 2001		
STATEMENT BY AFFLICANT	APPLICANT:	Erik Deutsch et al		
Sheet 2 of 2	GROUP ART UNIT:	2872	EXAMINER: Not Yet Assigned	

FOREIGN PATENT DOCUMENTS

Examiner's Initials#	Cite No.	Fo	reign Patent Docui	ment	Name of Patentee or Applicant of Cited Document (not necessary)	Date of Publication of Cited Document MM-DD-YYYY	Translation (Y/N)
		wo	01/11396	Ai		02-15-2001	
	ļ	EP	1 122 577 A2			08-08-2001	
		EP	1 143 287 A2			10-10-2001	

OTHER ART - NON PATENT LITERATURE DOCUMENTS

Examiner's Initials#	Cite No	Include name of the author (in CAPITAL LETTERS) title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, relevant page(s), volume-issue number(s), publisher, city and/or country where published.							

EXAMINER	DATE CONSIDERED

#EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



Serial No. 09/975/69 File No. P0793	7001 By: JBP
Title: ACTUABLE DIFFRACTIVE OPTIC	AL PROCESSOR
Application of Enik R. Deutsch ETAL.	WGS Date:
The U.S. PTO Mail Room acknowledges receipt of the following	on the date stamped hereon:
[] Mailing by Express Mail (37 CFR 1.10) Express Mail Label No	Provisional Application Cover Sheet Multiple Dependent Claim Fee Sheet Inf. Discl. Statement, PTO Form 1449 [x] References Cited Priority Document(s) # Copy of Notice to File Missing Parts Amendment/Response Petition for Ext. of Time (x2) Issue Fee Transmittal Letter to Official Draftsperson Notice of Appeal Brief (x3) Check for Check # Transmittal Letter (x2) Cert. of Mailing under 37 CFR 1.8(a)
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DATE MAILED 7-26-03	TRADET MARKET



Attorney's Docket No. P0743/7001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Erik R. DEUTSCH, Malcolm C. SMITH, Michael A. BUTLER and Stephen D. SENTURIA

Serial No.:

09/975,169

Filing Date:

October 11, 2001

For:

ACTUABLE DIFFRACTIVE OPTICAL PROCESSOR

Examiner:

Unassigned

Art Unit:

2872

Confirmation No. 9099

Commissioner for Patents Washington, D.C. 20231

Sir/Madam:

Transmitted herewith for filing is/are the following document(s):

[X] Supplemental Information Disclosure Statement

[X] PTO Form 1449 With Cited References

[X] Return Post Card

If the enclosed papers are considered incomplete, the Mail Room and/or the Application Branch is respectfully requested to contact the undersigned collect at (617)720-3500, Boston, Massachusetts.

No check is enclosed. If it is determined that a fee is necessary, the fee may be charged to the account of the undersigned, Deposit Account No. 23/2825. A duplicate of this sheet is enclosed.

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

I hereby certify that this document is being placed in the United States mail with first-class postage attached, addressed to the Commissioner for Patents, Washington, D.C. 20231 on July 26, 2002.

Respectfully submitted,

ERIK R. DEUTSCH et al.

Jeffrey B. Powers

Registration No. 45,021

WOLF, GREENFIELD & SACKS, P.C.

600 Atlantic Avenue

Boston, MA 02210

Tel. (617)720-3500

Attorneys for the Applicant(s)

Attorney's Docket No. P0743/7001



Attorney's Docket No. P0743/7001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Erik R. DEUTSCH, Malcolm C. SMITH, Michael A. BUTLER and Stephen D. SENTURIA

Serial No.:

09/975,169

Filing Date:

October 11, 2001

For:

ACTUABLE DIFFRACTIVE OPTICAL PROCESSOR

Examiner:

Unassigned

Art Unit:

2872

Confirmation No. 9099

Commissioner for Patents Washington, D.C. 20231

SUPPLEMENTAL STATEMENT FILED PURSUANT TO THE DUTY OF DISCLOSURE UNDER 37 CFR §1.56, 1.97 AND 1.98

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. §§1.56, 1.97 and 1.98, the Applicant requests consideration of this Information Disclosure Statement.

Compliance with 37 C.F.R. §1.97

This Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits in the above-identified case. No fee or certification is required.

Information Cited

The Applicant hereby makes of record in the above-identified application the information listed on the attached form PTO-1449 (modified). The order of presentation of the references should not be construed as an indication of the importance of the references.

REMARKS

Documents cited on the attached form PTO-1449 (modified) are enclosed unless otherwise indicated on the attached form PTO-1449 (modified). It is respectfully requested that:

1. The Examiner consider completely the cited information, along with any other information, in reaching a determination concerning the patentability of the present claims;

- 2. The enclosed form PTO-1449 be signed by the Examiner to evidence that the cited information has been fully considered by the Patent and Trademark Office during the examination of this application;
- 3. The citations for the information be printed on any patent which issues from this application.

By submitting this Information Disclosure Statement, the Applicant makes no representation that a search has been performed, of the extent of any search performed, or that more relevant information does not exist.

By submitting this Information Disclosure Statement, the Applicant makes no representation that the information cited in the Statement is, or is considered to be, material to patentability as defined in 37 C.F.R. §1.56(b).

By submitting this Information Disclosure Statement, the Applicant makes no representation that the information cited in the Statement is, or is considered to be, in fact, prior art as defined by 35 U.S.C. §102.

Notwithstanding any statements by the Applicant, the Examiner is urged to form his own conclusion regarding the relevance of the cited information.

An early and favorable action is hereby requested.

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

I hereby certify that this document is being placed in the United States mail with first-class postage attached, addressed to the Commissioner for Patents, Washington, D.C. 20231 on July 26, 2002.

Attorney's Docket No. P0743/7001

Respectfully submitted,

ERIK R. DEUTSCH et al.

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Registration No. 45,021

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Attorneys for the Applicant(s)

FORM PTO-1449/A and B (Modified)

INFORMATION DISCLOSURE

STATEMENT BY APPLICANT

APPLICATION NO.: 09/975,169 ATTY. DOCKET NO.: P0743/7001

FILING DATE: October 11, 2001

APPLICANT: Erik R. Deutsch et al.

2872

EXAMINER:

U.S. PATENT DOCUMENTS

6

of

Sheet

GROUP ART UNIT:

L'Adminici 9	Cite	U.S. Patent Docume	nt	Name of Patentee or Applicant of Cited	Date of Publication or of issue of Cited Document
	No.	Number	Kind Code	Document	MM-DD-YY
		3,553,364		Lee	01/05/71
	 	4,234,788		Palmer et al.	11/18/80
	 	5,022,745		Zayhowski et al.	06/11/91
		5,164,688		Larson	11/17/92
	 	5,168,249		Larson	12/01/92
		5,175,521		Larson	12/29/92
	 	5,206,557		Bobbio	04/27/93
	 	5,212,582		Nelson	05/18/93
	1 1	5,291,502		Pezeshki et al.	03/01/94
	1	5,353,641		Tang	10/11/94
	+	5,392,151		Nelson	02/21/95
	 	5,396,066		Ikeda et al.	03/07/95
		5,561,523		Blomberg et al.	10/01/96
	 	5,629,951		Chang-Hasnain et al.	05/13/97
	+	5,640,133		MacDonald et al.	06/17/97
		5,646,772		Yurke	07/08/97
	1	5,654,819		Goossen et al	08/05/97
	+	5,696,662		Bauhahn	12/09/97

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	Cite	Fore	eign Patent Docu		Name of Patentee or Applicant of Cited	Date of Publication of Cited	Translation
Examiner's Initials #	No.	Office/ Country	Number	Kind Code	Document (not necessary)	Document MM-DD-YY	(Y/N)
	 						

OTHER ART - NON PATENT LITERATURE DOCUMENTS

Examiner's	Cite	Include name of the author (in CAPITAL LETTERS) title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, relevant page(s), volume-issue number(s), publisher, city and/or country where published.	Translation
Initials #	No		(Y/N)
		ANALYSIS OF GRATING LIGHT VALVES WITH PARTIAL SURFACE ELECTRODES, FURLANI et al., J. Appl. Phys. 83 (2), 01/15/98, American Institute of Physics, pp 629-634	

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EXAMINER				,	DATE CONSIDERED
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#EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

^{*}a copy of this reference is not provided as it was previously cited by or submitted to the office in a prior application, Serial No. ________, filed ________, and relied upon for an earlier filing date under 35 U.S.C. 120 (continuation, continuation-in-part, and divisional applications).

6

FORM PTO-1449/A and B (Modified)

Sheet

APPLICATION NO.: 09/975,169

ATTY. DOCKET NO.: P0743/7001

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

FILING DATE:

October 11, 2001

APPLICANT:

Erik R. Deutsch et al.

GROUP ART UNIT:

2872

EXAMINER:

U.S. PATENT DOCUMENTS

Examiner's	Cite	U.S. Patent Doc	ument	Name of Patentee or Applicant of Cited	Date of Publication or of issue
Initials #	No.	Number	Kind Code	Document	of Cited Document MM-DD-YY
		5,739,945		Tayebati	01/14/98
		5,905,571		Butler et al.	05/18/99
		5,933,277		Troxell et al.	08/03/99
		5,949,568		Koo et al.	09/07/99
		5,966,235		Walker	10/12/99
		5,969,848		Lee et al.	10/19/99
		5,978,127		Berg	11/02/99
		5,998,906		Jerman et al.	12/07/99
		6,181,458		Brazas, Jr. et al.	01/30/01
		6,252,697		Hawkins et al.	06/26/01

FOREIGN PATENT DOCUMENTS

Examiner's Cite - No.	Cito	Fore	eign Patent Docu	ıment	Name of Patentee or Applicant of Cited	Date of Publication of	Translation
	Office/ Country	Number	Kind Code	Document (not necessary)	Cited Document MM-DD-YY	(Y/N)	
		wo	01/42825	A1	Gutin	06/14/01	
		wo	01/11410	A1	Thackara et al.	02/15/01	

OTHER ART - NON PATENT LITERATURE DOCUMENTS

Examiner's Initials #	Cite No	Include name of the author (in CAPITAL LETTERS) title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, relevant page(s), volume-issue number(s), publisher, city and/or country where published.	Translation (Y/N)
		POSITIONING, CONTROL, AND DYNAMICS OF ELECTROSTATIC ACTUATORS FOR USE IN OPTICAL AND RESYSTEMS, E.S. HUNG, 08/21/98 thesis Massachusetts Institute of Technology, 107 pages	
		MINIATURE FABRY-PEROT INTERFEROMETERS MICROMACHINED IN SILICON FOR USE IN OPTICAL FIBER WDM SYSTEMS, J.H. JERMAN et al., IEEE 1991 372, International Conf. On Solid-State Sensors and Actuators 1991, pp 372-375	·
		MICROMECHANICAL LIGHT MODULATOR ARRAY FABRICATED ON SILICON, K.E. PETERSEN, IBM Research Lab., Applied Physics Letters, Vol. 31, No. 8, 10/15/77, pp 521-523	
		<u>LEVERAGED BENDING FOR FULL-GAP POSITIONING WITH ELECTROSTATIC ACTUATION</u> , E.S. HUNG et al., MIT, Solid-State Sensor and Actuator Workshop Hilton Head Island, SC 06/08/98-06/11/98 pp 83-86	

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*a copy of this reference is not provided as it was previously cited by or submitted to the office in a prior application, Serial No. _______, filed ______, and relied upon for an earlier filing date under 35 U.S.C. 120 (continuation, continuation-in-part, and divisional applications).

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Sheet	3	of	6		GROUP ART UNIT: 2872	EXAMIN	IEK:		
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Initials #	O-1449/A and B (Modified) IFORMATION DISCLOSURE FATEMENT BY APPLICANT 3 of 6 S Cite No. Number Office/ Country Number OTHER ART- S Cite Include name of the author (in item (book, magazine, journa number) MEMS DEFORMABLE MIRRORS Eng., BU, Boston, MA, Solid ELECTROSTATIC EFFECTS IN MID Dept. of Aerospace a SIMULATING ELECTROSTRICTIC Lockheed Martin IN SIMULATING ELECTROSTRICTIC Lockheed Martin Missi DEVELOPMENT OF MICROELECT MALI et al., Dept. OPTICAL PHASE MODULATION DEFORMABLE MIRROR, COWA ADAPTIVE CONTROL OF ATABERRATION COMPENSATION ET al., Dept. of Aerospace a SURFACE MICROMACHINED S Selected Topics in MICROELECTROMECHANICAL Quantum				Document		MM-D		
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		MEMS DE Eng., BU,	FORMABLE MIRE	RORS FOR AL	PAPTIVE OPTICS, BIFANO, et al., Deptensor and Actuator Workshop Hiltor 06/11/98 pp 71-74	t. of Aerospa	ce and Mech. , SC 06/08/98-		
		ELECTROS	TATIC EFFECTS I	N MICROMAG	CHINED ACTUATORS FOR ADAPTIVE OP ch. Eng., BU, Boston, MA, J. of Elect	TICS, HOREN	NSTEIN, et al., 69-81		
			NG ELECTROSTR	ICTIVE DEFO	RMABLE MIRRORS: I. NONLINEAR STATES and Space, Smart Mater. Struct. 8, (IUS ANALYSIS	. HOM et al		
		SIMULA Loc	TING ELECTROST kheed Martin M	RICTIVE DE	FORMABLE MIRRORS: II. NONLINEAR D Space, Smart Mater. Struct. 8, (1999)	YNAMIC ANAI), 07/26/99,	<u>.xsis,</u> HOM, 07/26/99		
		DEVELOPM	ENT OF MICROFL MALI et al., D	ECTROMECTOR DEPT. of Aero	HANICAL DEFORMABLE MIRRORS FOR P Dispace and Mech. Eng., BU, Boston,	HASE MODUL MA, pp 542-	ATION OF LIGHT, 548		
		OPTICAL DEFORMA	PHASE MODULA BLE MIRROR, CO	TION USING DWAN et al	A REFRACTIVE LENSLET ARRAY AND M L., AFRL/MLP, Optical Engineering,	ICROELECTRO Vol. 37 No.	OMECHANICAL 12, 12/123/98,		
		ADAP ABERR	ITVE CONTROL O ATION COMPENS	F A MICROM ATION, ZHU	pp 3237-3247 ACHINED CONTINUOUS-MEMBRANE DE J et al., Applied Optics, Vol. 38, No.	FORMABLE M 1, 01/01/98,	URROR FOR pp 168-176		
		REAL TIME et al., D	OPTICAL CORRE	CTION USING	GELETROSTATICALLY ACTUATED MEM ch. Eng., BU, Boston, MA, J. of Elect	s DEVICES, 19	IORENSTEIN, 99, pp 69-81		
		SURFAC	EMICROMACHIN Selected Topics	ED SEGMEN s in Quantur	TED MIRRORS FOR ADAPTIVE OPTICS, C m Electronics, Vol. 5, No. 1, Jan/Feb	OWAN et a . 1999, pp 90	l., IEEE J. of 1-101		<u> </u>
		MICROEI	ECTROMECHAN Quan	ICAL DEFOR	MABLE MIRRORS, BIFANO et al., IEF onics, Vol. 5, No. 1, Jan/Feb. 1999, p	E J. of Selec p 83-89	ted Topics in		
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*a copy of this reference is not provided as it was previously cited by or submitted to the office in a prior application, Serial No. _ , and relied upon for an earlier filing date under 35 U.S.C. 120 (continuation, continuation-in-part, and divisional applications).

FORM PTO-1449/A and B (Modified)

APPLICATION NO.: 09/975,169 ATTY. DOCKET NO.: P0743/7001

INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

APPLICANT: Erik R. Deutsch et al.

GROUP ART UNIT: 2872 EXAMINER:

U.S. PATENT DOCUMENTS

Examiner's Initials # Cite No. Number Kind Code Number Code Name of Patentee or Applicant of Cited Document MM-DD-YY

FOREIGN PATENT DOCUMENTS Date of Foreign Patent Document Name of Patentee or Applicant of Cited Publication of Cite Examiner's Translation Document Cited No. Office/ Initials # Kind (Y/N) Number (not necessary) Document Country Code MM-DD-YY

OTHER ART - NON PATENT LITERATURE DOCUMENTS Include name of the author (in CAPITAL LETTERS) title of the article (when appropriate), title of the Cite Examiner's Translation Initials# No item (book, magazine, journal, serial, symposium, catalog, etc.), date, relevant page(s), volume-issue (Y/N) number(s), publisher, city and/or country where published. DESIGN AND FABRICATION OF 10X10 MICRO-SPATIAL LIGHT MODULATOR ARRAY FOR PHASE AND AMPLITUDE MODULATION, CHUNG et al., Sensors and Actuators 78, Elsevier Science S.A., 1999, pp 63-70 A DESIGN-BASED APPROACH TO PLANARIZATION IN MULTILAYER SURFACE MICROMACHINING, MALI et al., Dept. of Aerospace and Mech. Eng., BU, Boston, MA, Micromech. Microeng. 9 (1999) pp 294-299 VARIABLE GRATINGS FOR OPTICAL SWITCHING: RIGOROUS ELECTROMAGNETIC SIMULATION AND DESIGN, GANI et al., Opt. Eng. 38(3) 552-557, (March 1999) Soc. of Photo-Optical Ins. Eng. pp 552-557 DIFFERENTIAL CAPACITIVE POSITION SENSOR FOR PLANAR MEMS STRUCTGURES WITH VERTICAL MOTION, HORENSTEIN, et al., Dept. of Aerospace and Mech. Eng., BU, Boston, MA, Elsevier Science S.A. 07/12/99 pp 53-61 CONTINUOUS-MEMBRANE SURFACE-MICROMACHINED SILICON DEFORMABLE MIRROR, BIFANO et al., Soc. of Photo-Optical Ins. Eng. Opt. Eng. 36(5) May 1997, pp 1354-1360 MOCRO-ACTUATED MIRRORS FOR BEAM STEERING, GUSTAFSON et al., SPIE- Society of Photo-Optical Instrumentation Engineering, Vol. 3008, 1997, pp 90-99 DESIGNS TO IMPROVE POLYSILICON MICROMIRROR SURFACE TOPOLOGY, BURNS et al., SPIE-Society of Photo-Optical Instrumentation Engineering, Vol. 3008, 1997, pp 100-110 OPTICAL BEAM STEERING USING SURFACE MICROMACHINED GRATINGS AND OPTICAL PHASED ARRAYS, BURNS et al., SPIE, Vol. 3131, 1997, pp 99-110 INVESTIGATION OF THE MAXIMUM OPTICAL POWER RATING FOR A MICRO-ELECTRO-MECHANICAL DEVICE, BURNS et al., Internat'l Conf. On Solid-State Sensors and Actuators 06/16/97-06/19/97, pp 335-338

EXAMINER	DATE CONSIDERED

#EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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FOREIGN PATENT DOCUMENTS

Examiner's	Cite	For	eign Patent Docu	ıment	Name of Patentee or Applicant of Cited	Date of Publication of	Translation
Initials #	No.	Office/ Country	Number	Kind Code	Document (not necessary)	Cited Document MM-DD-YY	(Y/N)

OTHER ART - NON PATENT LITERATURE DOCUMENTS

Examiner's	Cite	Include name of the author (in CAPITAL LETTERS) title of the article (when appropriate), title of the	Translation
Initials#	No	item (book, magazine, journal, serial, symposium, catalog, etc.), date, relevant page(s), volume-issue number(s), publisher, city and/or country where published.	(Y/N)
		DEVELOPMENT OF MICROELECTROMECHANICAL VARIABLE BLAZE GRATINGS, BURNS et al., Elsevier Science S.A. Conf. On Solid-State Sensors and Actuators, 1998, pp 7-15	
		OPTICAL POWER INDUCED DAMAGE TO MICROELECTROMECHANICAL MIRRORS, BURNS et al., Elsevier Science S.A. Conf. On Solid-State Sensors and Actuators, Sensors and Actuators A 70 (1998), pp 6-14	
	•	MICRO-ELECTRO-MECHANICAL VARIABLE BALZE GRATINGS, BURNS et al., Air Force Institute of Technology, Dept. of Ele and Comp Eng., Wright-Patterson AFB, Ohio, pp 55-60	
		POLYMERIC TUNABLE OPTICAL ATTENUATOR WITH AN OPTICAL MONITORING TAP FOR WDM TRANSMISSION NETWORK, LEE et al., IEEE Photonics Tech. Ltrs, Vol. 11, No. 5, May 1999, pp 590-592	
		MICROMECHANICAL FIBER-OPTIC ATTENUATOR WITH 3 μ RESPONSE, FORD et al., IEEE, J. of Lightwave Technology, Vol., 16, No. 9 Sept. 1998 pp 1663-1670	
		MODELING, DESIGN, FABRICATION AND MEASUREMENT OF A SINGLE LAYER POLYSILICON MICROMIRROR WITH INITIAL CURVATURE COMPENSATION, MIN et al., Elsevier Science S.A., Sensors and Actuators 78 (1999) 8-17	
		SPECTRALLY SELECTIVE GAS CELL FOR ELECTROOPTICAL INFRARED COMPACT MULTIGAS SENSOR, MELÉNDEZ et al., Elsevier Science S.A., Sensors and Actuators 46-47 (1995) 417-421	
		SILICON MICROMACHINED INFRARED SENSOR WIHT TUNABLE WAVELENGTH SELECTIVITY FOR APPLICATION IN INFRARED SPECTROSCOPY, D. ROSSBERG., Elsevier Science S.A., Sensors and Actuators 46-47 (1995) 413-416	
		NONLINEAR FLEXURES FOR STABEL DEFLECTION OF AN ELECTROSTATICALLY ACTUATED MICROMIRROR, BURNS et al., Air Force Institute of Technology, Dept. of Ele and Comp Eng., Wright-Patterson AFB, Ohio, SPIE Vol. 3226, 1997, pp 125-136	

EXAMINER	DATE CONSIDERED

#EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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